SFUND RECORDS CTR 88172057

SFUND RECORDS CTR 2807-91886

CITY OF MOUNTAIN VIEW

		Application	on for Industrial	Wastes Discharge	Permit	013-7-		
Date A.	Name of Organization Fairchild Semiconductor, A Division of Fa Address Camera and Instrument Corporation, 464 Ellis St., A Address of Point of Discharge 313 Fairchild Dr., Bldg, 3 Individual Responsible Name Bernard-Yurash for industrial waste Signature Alexandra Guerral					No		
	Attach Map Showing Po			and Waste Treatmen	nt Facility.			
8.	Flow Rate: Average	590,000 g	als/day Max.	590,000 gals/day	Peak Ho	urly <u>409</u>	GPM	
C.	Submit separate statement. Detailing type of ind 2. Listing chemicals use 3. Describing waste treat. Giving characteristics 5. Concerning radioactif 6. Naming organic solve	ustry and natured and approximatment facilities to fexceptional ve wastes	iate concentrations industrial wastes	it point of discharge				
D.	Indicate the point of dis Biochemical oxygen der Chemical oxygen demar Total Solids, Average Suspended Solids, Avera Temperature	nand (B.O.D.) nd (C.O.D.)	ration of the follow 50 100 mg/1 500 mg/1 300 mg/1 60 •F	Grease and o Hydrogen to Fluoride	oil, total on content pH 1 . 5_	0 5.5 to 10	pplicable. ng/1 ng/1	
•	Arsenic Barium Beryllium Boron Chlorine Cadmium Chromium Hexavalent Chromium Total Cobalt Copper	Max. Conc. Allowable mg/1 0.1 5.0 1.0 1.0 1.0 2.0 1.0 1.0	Allowable Mass Emission Rate kg/day 0.01 0.5 0.1 0.1 5.0 0.01 0.1 0.	Formaldehyde Lead Manganese Mercury Nickel Chloroform Phenols Selenium Silver	Max. Conc. Allowable mg/1 5.0 0.5 1.0 0.05 1.0 50.0 1.0 2.0 5.0	Allowable Emission kg/day 0,5 0,05 0,1 0,005 0,1 5,0 0,1 0,2 0,5 0,5 0,5 0,5	Rate - -	
	Cresols Cyanides	2.0 1.0	0.2_	ZIIC	1. U	U.3	<u> </u>	
Permi Allen Signar	•	Wastes in Acco	ly	oplication Approved	and Specif	Attached ic Condit 13, 1976	1008	
List D	t to Discharge Exception letails: Shelley, Director of Pub ture		iste Kpproved	Date				

DISTRIBUTION: Original to Industrial Waste File, Copy to Discharger, Copy to Water Quality Control Plant, Copy to Palo Aito, Copy to Sawer Division.

(PW-23)

CITY OF MOUNTAIN VIEW

Industrial Waste Discharge Permit

DATE: April 13, 1976	NO. 013-7-79
NAME OF ORGANIZATION: Fair	hild Semiconductor
ADDRESS: 464 Ellis Stree	

GENERAL CONDITIONS

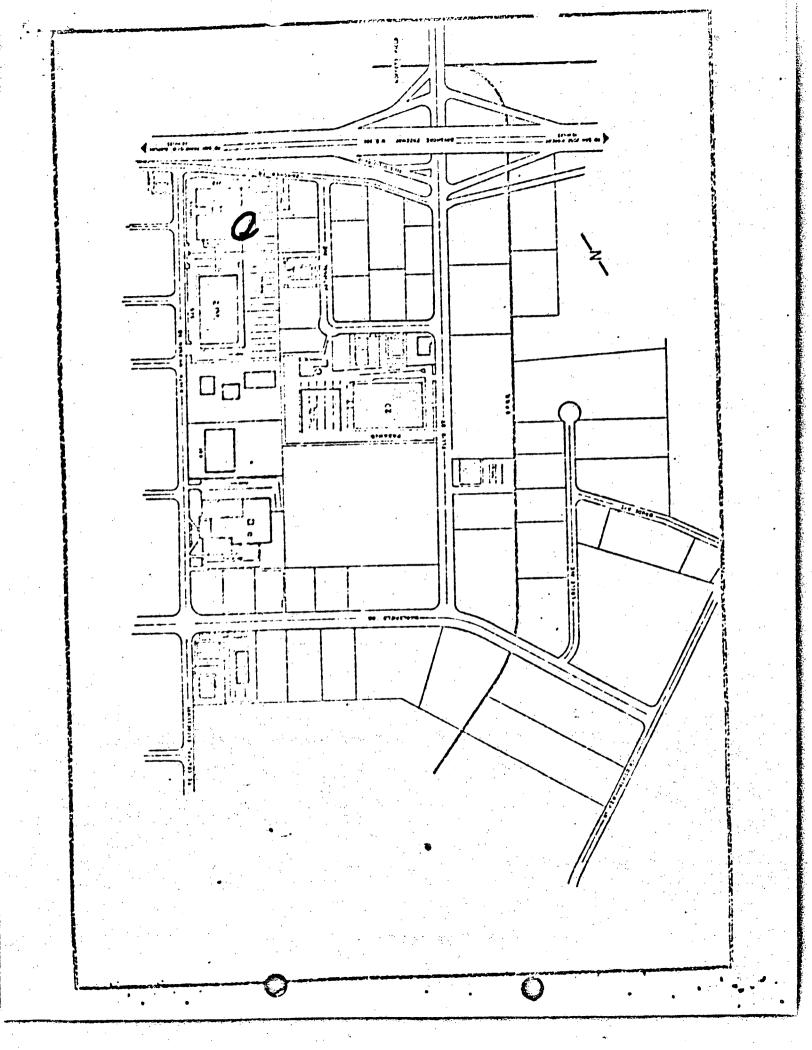
- 1. This permit is issued under the ordinances and regulations of the City of Mountain View currently in effect, but all discharges hereunder shall comply with all ordinances and regulations of the City and all other applicable local, state, and federal regulations, whether now in effect or hereafter adopted or amended.
- 2. Any violation of the terms of this Permit or the ordinances or regulations of the City shall be grounds for revocation.
- 3. If any proposed revisions in plant operations are expected to cause significant changes in waste water quality or quantity (25 percent or more, or 25,000 gallons per day) from that given in approved Permit information, an application for an amended permit must be submitted for approval detailing the nature of the changes.
- 4. In accordance with Section 35.32.8 of the City Code, accidental discharges of industrial wastes shall be reported immediately to the Public Works Department, telephone number 967-7211, Ext. 270, during normal office hours, or to the Fire Department, telephone number 968-4415, on holidays or after normal office hours AND to the Palo Alto Regional Water Quality Control Plant, telephone number 329-2598 so that appropriate countermeasures may be taken.
- This Permit is not transferable without prior written consent of the Director of Public Works. In general, a change of ownership will require a new permit.
- 6. The issuance of this permit does not constitute a warranty that the design capacity of the sewage collection and treatment system is sufficient to accommodate peak sewage flows from all dischargers who may now or hereafter be connected to the system. Pursuant to Sec. 35.32.1(d) the City reserves the right to impose restrictions on sewage discharges where necessary in the judgment of the City to assure the proper functioning in the sewerage system.

SPECIFIC CONDITIONS

- 1. This permit is for a period ending on July 1, 1977 but shall be automatically renewed for up to four (4) additional successive one-year periods unless the City shall give written notice of nonrenewal at least thirty (30) days prior to the annual renewal date.
- This permit applies to industrial waste discharges at the following location(s) only:

<u>Buildi</u>	ng 3 -	313	Fairchild	Drive	
			•		-
	*.				

^{3.} Your attention is called to the fact that flow rates shown on the permit application exceed per-acre design flows of the sewers serving the above locations. Restrictions or additional charges may be imposed in accordance with Sec. 35.32.1(d) of the City Code should peak sewage flows these sowers.



APPLICATION FOR INDUSTRIAL WASTES DISCHARGE PERMIT, ITEM C.

1. Type of Industry and Nature of Products

Pairchild Semiconductor processes silicon metal into electronic semiconductor devices.

2. Chemicals used in semiconductor device processing are:

Gases	Liquids	Liquids
Nitrogen Hydrogen Oxygen Argon Hydrogen chloride Chlorine Compressed air Ammonia	Sulfuric acid Nitric acid Hydrofluoric acid Hydrochloric acid Acetic acid Phosphoric acid Ammonium fluoride Ammonium hydroxide Acetone	Methanol Isopropanol Methylene chloride Trichloroethane Detergents Aluminum sulfate Sodium carbonate Sodium hydroxide Preon Glycerin Xylene

3. Waste treatment facilities

Neutralization of acids is provided by injection of ammonia into mixing tanks with continuous monitoring and control. Fluoride solutions are captured and disposed of separately, not into the city sewer.

In Building No. 18 a cyanide destruction system operates to destroy and convert cyanides to nitrogen and carbon dioxide. The final effluent is neutralized to a pH between 6 and 9.

- 4. Characteristics of exceptional industrial wastes. None.
- 5. No radioactive wastes are discharged.
- 6. Organic solvents are captured for storage and recycling.